



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

David L. Adler, et al

Application No. 10/017,860

Examiner: Ahmed, Samir Anwar

Filing Date: December 14, 2001

Art Unit: 2623

Title: Method and Apparatus for Inspecting a Substrate

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Honorable Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT AND RESPONSE TO OFFICE ACTION**

Sir:

This submission is responsive to the Final Office Action mailed on March 28, 2006 and the Advisory Action mailed on June 13, 2006. This submission is being filed along with a Request for Continued Examination for this application.

Applicants hereby requests non-entry of the previously filed unentered amendment which was mailed on May 26, 2006. Instead, applicants would like to amend the claims in accordance with the present submission.